

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITU et al.

Group Art Unit: 1792

Application No.: 10/509,177

Examiner: M. SONG

Filed: September 27, 2004

Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR
A1-CONTAINING III-V GROUP COMPOUND
SEMICONDUCTOR, AND METHOD AND
DEVICE FOR PRODUCING A1-
CONTAINING III-V GROUP COMPOUND
SEMICONDUCTOR

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

The fees associated with this filing are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



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JAO:ABW/tca

Date: May 11, 2009

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
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